

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 22, 2025

IGI Report Number

LG735587580

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

PRINCESS CUT

Measurements

7.66 X 7.54 X 5.42 MM

GRADING RESULTS

Carat Weight

2.83 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT


Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG735587580

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS

Medium To Slightly Thick


12.5%

68%

54%

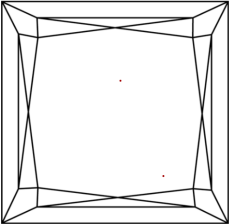
71.9%

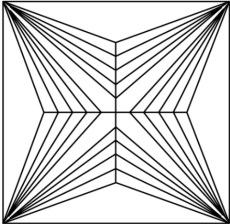
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Sample Image Used

CLARITY CHARACTERISTICS





KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

IF VVS ¹⁻² VS ¹⁻² SI ¹⁻² I ¹⁻³


Internally Flawless


Very Very Slightly Included

Very Slightly Included

Slightly Included

Included






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
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Culet

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